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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	TOT CLAIMS	IND CLAIMS
10/582,099	03/19/2007	1641	1280	03500.103394.	25	1

**CONFIRMATION NO. 1165**

5514  
FITZPATRICK CELLA HARPER & SCINTO  
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NEW YORK, NY 10112

**CORRECTED FILING RECEIPT**



\*OC000000026658962\*

Date Mailed: 11/08/2007

Receipt is acknowledged of this non-provisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections

**Applicant(s)**

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**Assignment For Published Patent Application**

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**Power of Attorney:** The patent practitioners associated with Customer Number 5514

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP04/18962 12/13/2004

**Foreign Applications**

JAPAN 2003-418560 12/16/2003

**If Required, Foreign Filing License Granted:** 08/01/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US 10/582,099**

**Projected Publication Date:** Not Applicable

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Substrate for Cell Culture, Producing Method Thereof and Screening Method for Cell Culture Conditions Utilizing the Same

**Preliminary Class**

435

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